

LOGITECH WSB2 WAFER SUBSTRATE BONDING UNIT

Bonding Specifications:

- **Bond Equipment** : Logitech WSB2 Wafer to Substrate Bonder.
- **Bond Temp** : 85 C.
- **Wax Soak Time** : 5 mins.
- **Bond Time** : 15 mins.
- **Bond Wax** : Quartz .
- **Vacuum Level** : 1.5 to 3.5 E-1mbar.
- **Applied Pressure** : 15 psi

